

#3 1-31-01

1  
2  
3  
4  
5  
6  
7  
8  
9  
10  
11  
12  
13  
14  
15  
16  
17  
18  
19  
20  
21  
22

Inventor: Garry A. Mercaldi  
Title: Low Selectivity Deposition Methods  
Assignee: Micron Technology, Inc.  
Serial No.: 09/643,004  
Filing Date: August 21, 2000



**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98**

In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is directed to the U.S. Patents and other documents listed on the attached Form PTO-1449, and copies of which are attached. No admission is made regarding whether the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 22 Jan 2001

Attorney: [Signature]  
James E. Lake  
Reg. No. 44,854  
WELLS, ST. JOHN, ROBERTS,  
GREGORY & MATKIN P.S.  
601 W. First Ave., Suite 1300  
Spokane, WA 99201-3828  
(509) 624-4276

RECEIVED  
JAN 30 2001  
TECHNOLOGY CENTER 2800  
AT-USVD-04